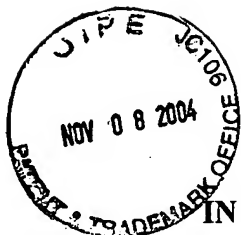


IFW



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:	)	
	)	
Wang	)	Group Art Unit: 2814
	)	
Serial No.: 10/662,909	)	Examiner: Weiss, Howard
	)	
Filed: September 15, 2003	)	Confirmation No. 1239
	)	
For: Thin Film Transistor Structure and	)	TKHR Docket No.: 250317-1060
Method of Manufacturing the Same	)	Top-Team Ref. US0822PA
	)	
	)	

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on November 4, 2004.

Signature – Hui Chin Barnhill

**RESPONSE TO RESTRICTION REQUIREMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed October 12, 2004, has been carefully considered. In response thereto, please consider the following remarks.